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INFORMATION DISCLOSURE STATEMENT
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APPLICANT

Peter C. Van Buskirk, et al.

FILING DATE

June 8, 1998

GROUP

1763

1746

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | PATENT NUMBER | ISSUE DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| | AA | 08/975,366 | | Van Buskirk and Kirlin | | | 11/20/98 |
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FOREIGN PATENT DOCUMENTS

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EXAMINER

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| EXAMINER <i>W. C. Olson</i> | | | | | DATE CONSIDERED 9/29/89 | | |
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